

Docket No.: USS-18302/16  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Subhendu Guha et al.

Application No.: 10/765,435

Confirmation No.: 1518

Filed: January 27, 2004

Art Unit: 2892

For: METHOD FOR DEPOSITING HIGH-  
QUALITY MICROCRYSTALLINE  
SEMICONDUCTOR MATERIALS

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Examiner: T. Y. Tran

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Madam:

**INTRODUCTORY COMMENTS**

This patent application is under final rejection and it is presently under appeal. Prosecution has been closed, and pursuant to 35 U.S.C. §132, Applicant has filed a request for continuing examination to reopen prosecution of this application. In that regard, Applicant submits herewith the present amendment and remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.